



PATENT

Atty. Dkt. No. AMAT/3980/CPI/COPPER/PJS

#1762

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

Parkhe, et al.

Serial No.: 09/505,638

Confirmation No.: 7404

Filed: February 16, 2000

For: Chemical Vapor Deposition
of Barriers from Novel
Precursors

Group Art Unit: 1762

Examiner: Bret P. Chen

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on
12/18, 2003 with the United States Postal Service as
First Class Mail in an envelope addressed to: Commissioner
for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.12/18/03
Date[Signature]
Signature

Dear Sir:

RESPONSE TO OFFICE ACTION DATED SEPTEMBER 26, 2003

In response to the Office Action dated September 26, 2003, having a shortened statutory period for response set to expire on December 26, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3980/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 8 of this paper.